

Tin oxide micro/nano fibers from electrostatic deposition

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SnO₂ micro/nano fibers in the rutile structure were synthesized using electrospinning and metallorganic decomposition techniques. Fibers were electrospun using two different precursor solutions, one based on SnCl₄ and the other on C₂₂H₄₄O₄Sn. The fibers were sintered in air for two hours at 400, 500, 600, 700 and 800°C. SEM, AFM, XRD, XPS and Raman microspectrometry were used to characterize the sintered fibers. The results showed that the fibers were composed of SnO₂ and that the SnCl₄ precursor led to better results in terms of uniformity/continuity of the fibers.

Keywords: Tin oxide; nanofibers; electrospinning.

Micro/nano fibras de SnO₂ rutilo se sintetizaron con electrospinning y técnicas de descomposición metalo-orgánicas. Las fibras se produjeron utilizando dos soluciones precursoras distintas basadas en una mezcla de SnCl₄ y otra de C₂₂H₄₄O₄Sn. Las fibras se quemaron en aire por dos horas a temperaturas de 400, 500, 600, 700 y 800°C y se analizaron utilizando SEM, AFM, XRD, XPS y microscopía Raman. Los resultados muestran que las fibras producidas con ambos precursores están compuestas de SnO₂ y que la solución precursora con SnCl₄ produce fibras más uniformes y continuas.

Descriptores: Óxido de estaño; nanofibras; electrospinning.

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1. Introduction

Tin oxide, SnO₂ is an n-type semiconductor with a large bandgap ($E_g=3.6\text{eV}$ at 300K). The use of SnO₂ thin films as chemical sensors for environmental and industrial applications has been studied intensively [1-3]. SnO₂ in the form of fibers is expected to have improved chemical sensing characteristics [4]. The effective surface area for sensor applications depends on the total grain boundary (GB) area in the SnO₂ sensing element. The GB area-to-volume ratio will increase with the reduction in grain size. If we can fabricate the element in the form of fibers with their diameter on the nano scale, the grain size will be reduced due to restriction the grain growth along the cross-section of the fibers, and fibers are expected to be more sensitive than a thin film. Efforts to synthesize the structures include the development of nanofibers, nanowires, nanorods, and nanobelts [5-10]. Of the methods used to produced the nanostructures, electrospinning is especially interesting in that it is easy and cost effective [6,8,9].

As the active element in chemical or biological sensors, the tin oxide nanofibers can be configured either as resistors whose conductance is altered by charge-transfer processes occurring at their surfaces, or as field-effect transistors whose properties can be controlled by applying an appropriate potential to their gate [11]. The conductivity of the SnO₂ semiconductor is modulated by the chemisorbed oxygen molecules on its surface. The absorbed oxygen, receiving electrons from the conduction band, produces an electron

depletion layer under the absorbing surface and a potential barrier between particles, and thus decreases the conductivity of the SnO₂ [4]. This makes SnO₂ a good candidate as a gas sensor whose conductivity will increase sharply when exposed to a reducing gas. Sensors based on SnO₂ wires using the conductance or field effect transistor configuration have been reported [10-12] with good electrical and photoconduction properties.

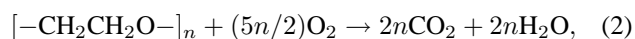
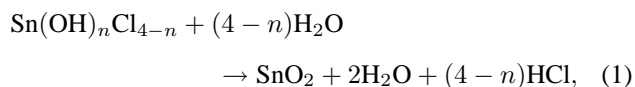
2. Formation process

Fibers were electrospun from two simple precursor solutions. For both solutions, the viscosity was controlled using a solution of poly(ethylene oxide) (PEO) [-CH₂CH₂O-]_n (molecular weight 900,000 Aldrich) and chloroform (CHCl₃ Sigma). The SnCl₄ solution [8] was prepared using anhydrous tin(IV) chloride (SnCl₄ ACROS Organics), deionized water, propanol (C₃H₇OH, Fischer Scientifics), and isopropanol (2-C₃H₇OH, Fischer Scientifics) SnCl₄:H₂O:C₃H₇OH:2-C₃H₇OH in the following molar ratio: 1:9:9:6. Then the SnCl₄ solution was combined with the viscous solution (200 mg PEO/10 ml CHCl₃) at a volume ratio of 1:1.25. The C₂₂H₄₄O₄Sn solution [9] was made using liquid dimethyldineodecanoate tin combined with the viscous solution (100 mg PEO/10 ml CHCl₃) at a volume ratio of 2:1. The fibers were produced using a simple electrospinning setup, described in more detail elsewhere [13], followed by sintering using a resistance furnace with a Sentry 2.0 digital temperature controller made by Paragon Industries, Inc.

3. Characterization

SEM and SPM observations revealed that the horizontal diameter of sintered fibers ranges from 60 nm to 10 μm . Figure 1 shows a typical image of a single fiber. Figure 2 shows the SPM apparent average cross-section profile. It is a distortion of the actual profile because the tip not only has its own cone shape and size, but also cannot trace the lower part of the fiber. However, the vertical dimension (diameter) of 100 nm is not distorted and is therefore accurate. The SEM and SPM analysis indicates that the SnCl_4 precursor led to better results in terms of uniformity/continuity of the fibers.

Figure 3 shows the XRD spectra for fibers electrospun using the SnCl_4 precursor. After sintering at 400°C, 110, 101 and 211 XRD peaks of rutile structure SnO_2 appear, indicating the formation of its recipient lattice. These peaks become more distinct and an additional 200, 220 and 310 peaks showed up after sintering at 600°C, indicating the development of a more integral rutile lattice between 400°C and 600°C. Up to 800°C, all peaks are still identified as SnO_2 peaks, suggesting the following overall chemical reactions:



and $n = 0, 1, 2, 3, 4$.

For sintering temperatures of 400, 600 and 800°C, the relative intensities of the diffraction peaks are consistent with those reported in Ref. [14].

Typical Raman micro-scattering spectra are presented in Fig. 4. After sintering at 400°C, a peak around 631cm^{-1} shows up, whereas another weak peak centered around 774cm^{-1} begins to appear. The two peaks become more distinct after sintering between 600 and 800°C, whereas the third peak appears around 474cm^{-1} after sintering at 800°C. The SnO_2 rutile structure belongs to the space group

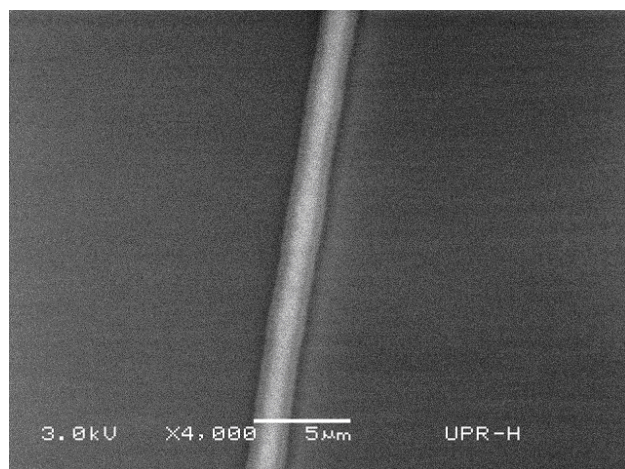


FIGURE 1. SEM micrograph of a single fiber sintered at 600°C for 2 hours.

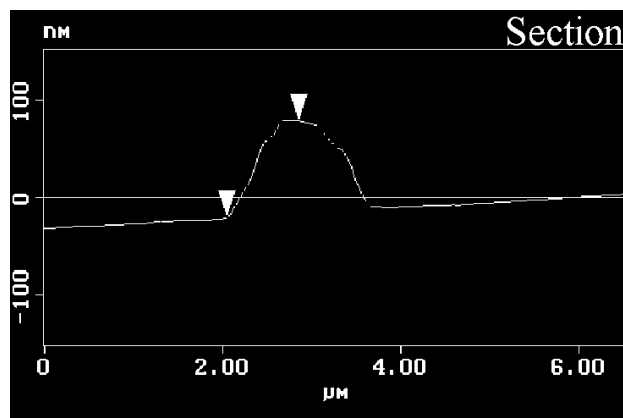


FIGURE 2. SPM apparent average cross-section profile of a single fiber sintered at 600 °C for 2 hours.

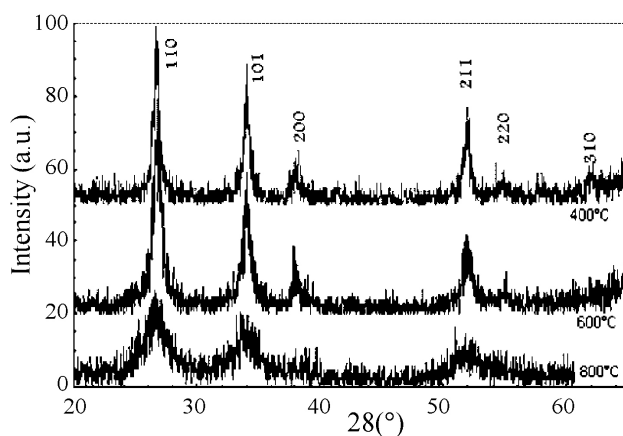


FIGURE 3. XRD Spectra for SnCl_4 -based fibers at different temperatures.

$P4_2/mnm$ [15]. Its normal lattice vibration at the Γ point of the Brillouin zone is

$$\Gamma = 1A_{1g} + 1A_{2g} + 1A_{2u} + 1B_{1g} + 1B_{2g} + 2B_{1u} + 1E_g + 3E_u. \quad (3)$$

Of the 11 optical phonons of symmetry, A_{1g} , B_{1g} , B_{2g} , and E_g are Raman active with the strongest Raman intensity at 631.3cm^{-1} for mode A_{1g} , followed by the mode B_{2g} at 774.4cm^{-1} and the mode E_g at 474.0cm^{-1} (B_{1g} peak is centered at $87 \pm 2\text{cm}^{-1}$). The peak position and relative intensity of A_{1g} , B_{2g} and E_g modes are in agreement with those observed in a large ($\sim 1\text{cc}$) natural cassiterite crystal [15] or synthesized SnO_2 nanorods [5]. It is noteworthy that after sintering at 800°C, two peaks appear around 605 and 708cm^{-1} . They cannot be attributed to any mode of lattice vibration in rutile SnO_2 , implying a subtle structure change that XRD is not so sensitive to detect.

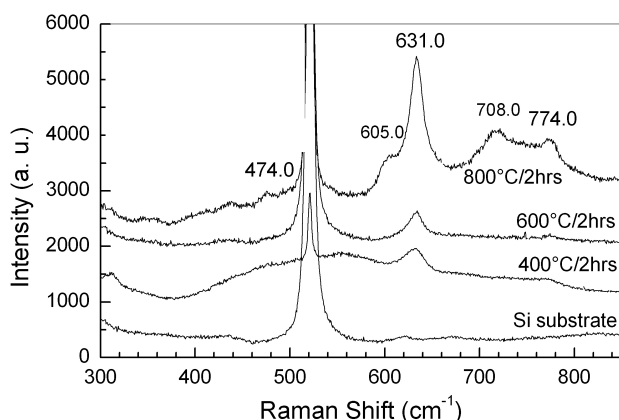


FIGURE 4. Raman micro-spectra of Si substrate and SnCl_4 -based mats sintered at different temperatures.

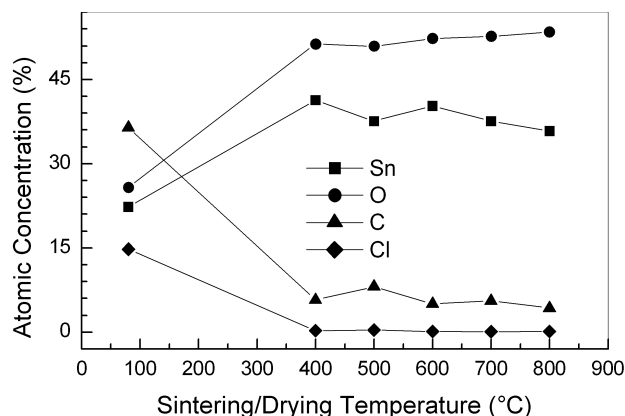


FIGURE 5. Sintering temperature dependence of the atomic concentration of SnCl_4 -based fibers.

The XPS spectra indicated the existence of elements Sn, O, C and Cl, as well as Si in sintered mat samples [16]. The XPS spectra for the Sn, O, C and Cl regions give the relative intensity of the elements as a function of the binding energy for mats sintered at 400, 500, 600, 700 and 800°C. Using the

atomic sensitivity factor, the relative atomic concentrations of Sn, O, C and Cl were analyzed semi-quantitatively and their dependence on the sintering temperature is shown in Fig. 5. Upon sintering at 400°C, Cl almost disappears; C concentration decreases sharply from 36.4% to 5-8%, whereas O concentration increases to more than 50%, and Sn concentration increases to 38%. The drastic decrease of carbon concentration and the regular shift of the XPS C1s peak caused by sintering suggest that the carbon is a residual element rather than an adventitious extrinsic impurity. We are currently investigating the properties of the sintered tin oxide fibers and their dependence on the preparation conditions and shall report the results in a coming paper.

4. Conclusion

Tin oxide (SnO_2) fibers, in the rutile phase with diameters ranging from 60nm to several microns were synthesized using two different precursor solutions. The first was a mixture of $\text{C}_{22}\text{H}_{44}\text{O}_4\text{Sn}$, and the second a mixture of SnCl_4 sol. In both cases the viscosity was controlled using a poly(ethylene oxide) (molecular weight 900,000)/chloroform solution. The fibers were fabricated using electrospinning and metallorganic decomposition techniques. Scanning electron microscopy, scanning probe microscopy, x-ray diffraction, Raman microspectrometry and x-ray photoelectron spectroscopy were used to characterize the sintered fibers. The results showed that a series of chemical reactions resulted in SnO_2 fibers in rutile structure at sintering temperatures between 400 and 700°C, and that the SnCl_4 precursor led to better results in terms of uniformity/continuity of the fibers.

Acknowledgements

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